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500.34397CV2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: H. MIURA, et al  
Application No.: 09/977,207  
Filed: October 16, 2001  
For: SEMICONDUCTOR DEVICE AND PRODUCTION THEREOF  
Group: 2823  
Examiner: J. Maldonado

RESPONSE

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 15, 2004

Sir:

In response to the Office Action mailed June 15, 2004, Applicants respectfully elect the Group I claims (that is, claims 15-33, 35 and 36), drawn to a method of manufacturing a semiconductor device, for examination on the merits in the present application. This election is made without traverse.

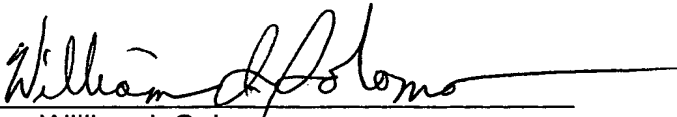
Examination of the Group I claims, on the merits, in due course, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Antonelli, Terry, Stout & Kraus, LLP

Deposit Account No. 01-2135 (Docket No. 500.34397CV2), and please credit any excess fees to such Deposit Account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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